

Docket No.: 063979-0027



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Gaku SUGAHARA, et al. : Confirmation Number: 3885
Application No.: 10/611,851 : Group Art Unit: 2828
Filed: July 03, 2003 : Examiner: James A. Menefee

For: NITRIDE SEMICONDUCTOR LASER DEVICE AND FABRICATING METHOD
THEREOF

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 30, 2005, having a three-month shortened statutory period for response set to expire November 30, 2005, and the petition for a one-month extension of time up to and including December 30, 2005 being filed concurrently herewith, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.